

1763/105
[10191/1690] #6

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants
Serial No.

Filed : May 8, 2001

For : DEVICE AND METHOD FOR ETCHING A SUBSTRATE
USING AN INDUCTIVELY COUPLED PLASMA

Examiner : L. Alejandro certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on

Art Unit : 1763 Dated: 1/16/03

Commissioner for Patents
Washington, D.C. 20231

Reg. 41,172

Signature: Do Magat

DERVIS MAGISTRE
KENYON & KENYON

ELECTION TRANSMITTAL

SIR:

Please find an Election With Traverse transmitted herewith for filing in the
above-identified patent application.

Applicants hereby request a three-month extension of time. The extended
period for response ~~expires on January 25, 2003~~. Please charge the \$930.00 extension fee and
any other fee that may be required to Deposit Account No. 11-0600. A duplicate of this
Transmittal is enclosed.

Respectfully submitted,

KENYON & KENYON

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Dated: 1/16/03